



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert Bristol et al.

Serial No.: 10/679,816

Filed: October 6, 2003

For: Enhancing Photoresist  
Performance Using Electric Fields

§ Group Art Unit:

§ Examiner:

§ Atty. Dkt. No.: ITL.1023US  
(P16710)

§ Assignee: Intel Corporation

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant submits the references listed on the attached form PTO 1449, copies of which are enclosed. A copy of a communication dated November 24, 2005 from a foreign patent office in a counterpart application is also enclosed. I, the undersigned, hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.1023US).

Respectfully submitted,

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Date of Deposit: December 7, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Monica Jacobs

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)			ATTY DOCKET NO. ITL.1023US (P16710)	SERIAL NO. 10/679,816
			APPLICANT(S): Robert Bristol et al.	
			FILING DATE: October 6, 2003	GROUP ART UNIT:

DEC 12 2005

**U.S. PATENT DOCUMENTS**

*EXAMINER'S INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A.	5,648,000	07/15/1997	Yamazaki et al.			
B.	5,783,362	07/21/1998	Wakiya et al.			
C.	6,103,145	08/15/2000	Angelopoulos et al.			
D.						
E.						

**U.S. PATENT APPLICATION PUBLICATIONS**

F.	2002/0046703	04/25/2002	Templeton			
G.	2003/0008246	01/09/2003	Cheng et al.			
H.						
I.						
J.						

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
K.	JP 57-32632	02/22/1982	Japan			Abstract Only	
L.	JP 63-71842	04/01/1988	Japan			Abstract Only	
M.	JP 63-244622	10/12/1988	Japan			Abstract Only	
N.	JP 10-106930	04/24/1998	Japan			Abstract Only	
O.							

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

P.	
Q.	
R.	
S.	
T.	
U.	
V.	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.